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Application Data Sheet 37 CFR 1.76				76	Attorney Docket Number			I431.175.101/FIN592PCT/US		
Application Data Sheet 37 Cl K 1.70				., 0	Application Number					
Title of	Title of Invention BASE SEMICONDUCTOR COMPONENT FOR A SEMICONDUCTOR COMPONENT STACK AND METHOR THE PRODUCTION THEREOF						1ETHOD			
bibliogra This doc	The application data sheet is part of the provisional or nonprovisional application for which it is being submitted. The following form contains the bibliographic data arranged in a format specified by the United States Patent and Trademark Office as outlined in 37 CFR 1.76. This document may be completed electronically and submitted to the Office in electronic format using the Electronic Filing System (EFS) or the document may be printed and included in a paper filed application.									
Secre	Secrecy Order 37 CFR 5.2									
1 1	Portions or all of the application associated with this Application Data Sheet may fall under a Secrecy Order pursuant to 37 CFR 5.2 (Paper filers only. Applications that fall under Secrecy Order may not be filed electronically.)									
Applio	cant Info	rmation:								
Applic	ant 1								Remove	
Applic	ant Authori	ty • Inventor	CLega	ıl Rep	resentativ	e under 3	35 U.S.C. 117	7	Party of Interest under 35 U.S.	.C. 118
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Addres	ss 1	Schloss	steig 21							
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Application Data Sheet 37 CFR 1.76				orney Do	ocket Number	l431.175.1	01/FIN592PCT/	US
Application Bata officer of Killing			Ар	plication	Number			
Title of Invention BASE SEMICONDUCTOR COMPONENT FOR A SEMICONDUCTOR COMPONENT STACK AND M FOR THE PRODUCTION THEREOF						ACK AND METHOD		
Customer Number		25281						
Email Address		sdicke@dbclaw.cor	m				Add Email	Remove Email
Email Address		uweeks@dbclaw.co	om				Add Email	Remove Email
Application In	forma	ation:						
Title of the Invention	on	BASE SEMICOND METHOD FOR TH				EMICONDU	CTOR COMPON	NENT STACK AND
Attorney Docket N	umber	I431.175.101/FIN5	92PC	T/US	Small Ent	tity Status (Claimed	
Application Type		Nonprovisional						
Subject Matter		Utility						
Suggested Class (if any)				Sub Clas	s (if any)		
Suggested Techno	ology C	enter (if any)						
Total Number of D	rawing	Sheets (if any)			Suggeste	d Figure fo	or Publication	(if any)
Publication Inform	ation:							
Request Early	Publica	tion (Fee required a	at time	e of Requ	uest 37 CFR 1.2	219)		
and certify tha	t the inv	n. I hereby request vention disclosed in ther country, or und	the a	ttached	application has	not been ar	nd will not be th	ne subject of an
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Please Select One:		Customer Number	er	∩ US	Patent Practitione	er O U	IS Representativ	re (37 CFR 11.9)
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Domestic Priority Information: This section allows for the applicant to claim benefit under 35 U.S.C. 119(e), 120, 121, or 365(c). Providing this information in the application data sheet constitutes the specific reference required by 35 U.S.C. 119(e) or 120, and 37 CFR 1.78(a)(2) or CFR 1.78(a) (4), and need not otherwise be made part of the specification.								
Prior Application	Status						Remo	ove
Application Num	nber	Continuity	Туре)	Prior Applicati	on Number	Filing Date	(YYYY-MM-DD)
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Application Da	nta Sheet 37 CFR 1.76	Attorney Docket Number	I431.175.101/FIN592PCT/US
Application Be	ita onceror or it i.ro	Application Number	
Title of Invention	BASE SEMICONDUCTOR C FOR THE PRODUCTION TH		DUCTOR COMPONENT STACK AND METHOD

Foreign Priority Information:

	- .	ority and to identify any prior foreign application eet constitutes the claim for priority as required	•
		Re	emove
Application Number	Country ⁱ	Parent Filing Date (YYYY-MM-DD)	Priority Claimed
10 2004 010 614.2	DE	2004-03-02	Yes ○ No
		Re	move
Application Number	Country ⁱ	Parent Filing Date (YYYY-MM-DD)	Priority Claimed
PCT/DE2005/000307	EP	2005-02-23	Yes No
Additional Foreign Priority Add button.	Data may be generated within	this form by selecting the	Add

Assignee Information:

•	in the application data sheet signment recorded in the Offi		stitute for compliance wi	ith any requirem	nent of part 3 of Title 37			
Assignee 1 Remove								
If the Assignee is an Organization check here.								
Organization Name	zation Name Infineon Technologies AG							
Mailing Address Infor	Mailing Address Information:							
Address 1	StMartin-Str. 53							
Address 2								
City	Munich		State/Province					
Country DE			Postal Code	81669				
Phone Number			Fax Number					
Email Address								
Additional Assignee Dabutton.	Additional Assignee Data may be generated within this form by selecting the Add putton.							

Signature:

_	A signature of the applicant or representative is required in accordance with 37 CFR 1.33 and 10.18. Please see 37 CFR 1.4(d) for the form of the signature.					
Signature	/Steven E. Dicke/		Date (YYYY-MM-DD)	2006-08-31		
First Name	Steven E.	Last Name	Dicke	Registration Number	38431	

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Application Da	ta Sheet 37 CFR 1.76	Attorney Docket Number	I431.175.101/FIN592PCT/US	
Application be	ita officer of or it 1.70	Application Number		
Title of Invention	BASE SEMICONDUCTOR C FOR THE PRODUCTION TH		DUCTOR COMPONENT STACK AND METHOD	

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